

825-UVC P.C.R. Chamber

Manufacturer:
Plas-Labs, Inc.
917 E. Chilson Street
Lansing, Michigan 48906
U.S.A.

European Agent:
Beun-de-Ronde, B.V.
Bovenkamp 9
1391 La Abcoude
Nederlands

The 825-UVC, P.C.R. Chamber, has been designed to help improve the accuracy of P.C.R.* and general Tissue Culture procedures. The chance for air-borne contamination during D.N.A. sequencing is greatly reduced. The chamber is a "still air enclosure" which contains both fluorescent and U.V. germicidal lamps.

Compliance under the following Directives and Standards:

89/336/EEC (Electromagnetic Capability)
EN 55011:1990 Class B
EN 61010-1:1993
EN 60555-2:1985 Harmonics
EN 60555-3:1982 Voltage Fluctuations
IEC 801-2 Electrostatic Discharge (ESD)
IEC 801-3 Radiated Electromagnetic Susceptibility
IEC 801-4 Electrical Fast Transient/Burst (EFT)